Search for weld pit formation mechanisms: Weld coupon EP

C Thompson, D Hicks, D Burk, R Schuessler
N Dhanaraj, M Steinke, M Foley, D Ford, L Cooley
Bill Starch – FSU
Welders at AES, Roark, Pavac





Motivation, Objectives, Techniques

- What causes pits?
 - Material state? Annealed vs cold worked Nb
 - Weld defect? Test welded vs no-weld coupons
 - Something wrong during EP?
 Temperature, flow, cathode area were varied
- How do we assess surface quality?
 - Number of pits or defects
 - Gloss (GU)
 - Roughness
 - -400 GU = 0.5 nm Ra

- Techniques
 - Parallel plates in a bath, with flow thru a heat exchanger, 14 V, 50 mA/cm²
 - Scan coupon with flat-bed scanner, Analyze images (subjective)
 - Follow-up with profilometer
 - Compare vs EP parameters and "quality" measurements
- QC
 - Removal rate was proportional to current
 - Removal rate prop. to temp.
 - Our removal rate lower than JLab's coupon EP

Important results to take away

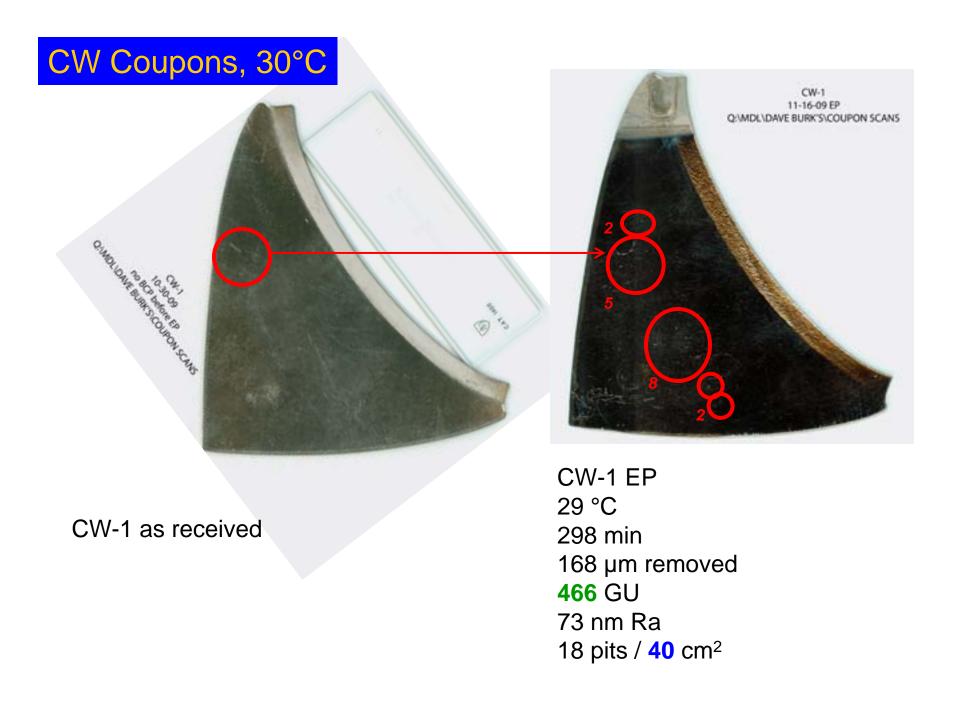
- For reasons we do not understand, a small cathode (1:20 area ratio) produced grain texture similar to what we see in cavities
 - Increasing temperature amplified this effect on one sample
 - 1:1 area ratio produces no grain contrast whatsoever
- Cold-working increases tendencies to form pits
 - But CW coupons are very glossy, too!
- Higher temperature increases tendencies to form pits
- Annealing decreases tendencies to form pits

Annealed Coupons, 30°C



EP-11
31 °C 303 min
263 µm removed
410 GU
20:1 anode:cath

EP-4 31 °C 120 min, 160 µm removed 456 GU 110 nm Ra 4 pits / 50 cm² 1:1 anode:cath



Cold-worked coupons RF SIDE and reduced to 72 dpi



12-10-09 Q:\MDL\DAVE BURK'S\COUPON SCANS CAT. 1400

CW-2 30 °C 300 min

193 µm removed

465 GU

30 nm Ra

16 pits / 40 cm²

CW-3

31 °C

298 min

189 µm removed

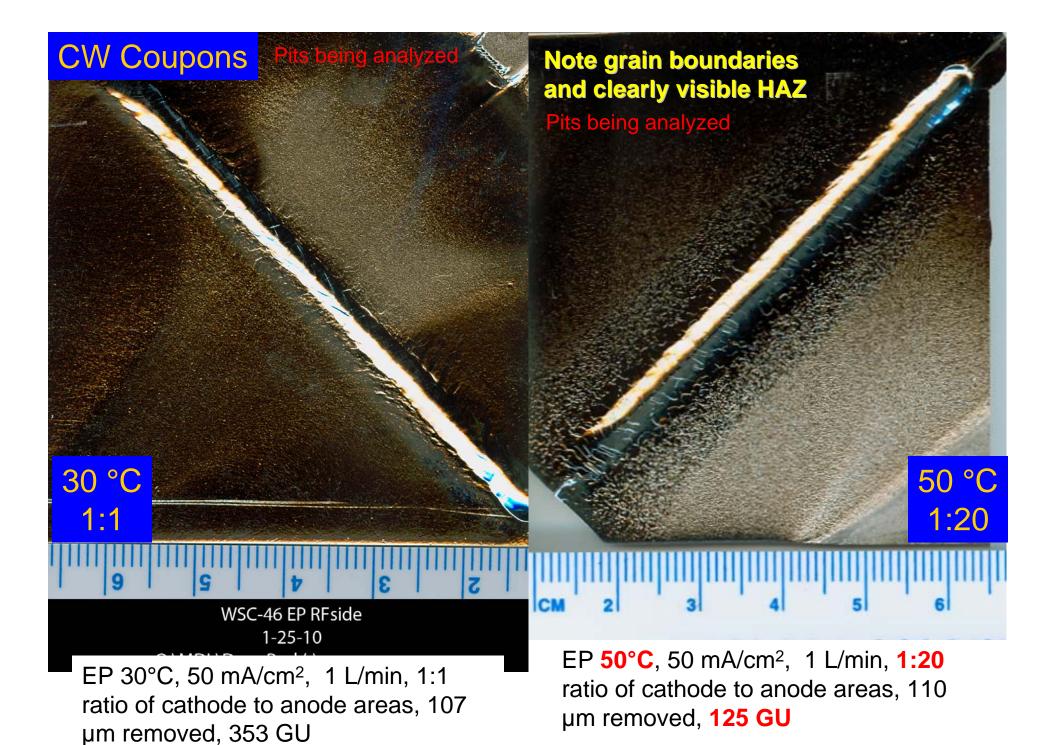
422 GU

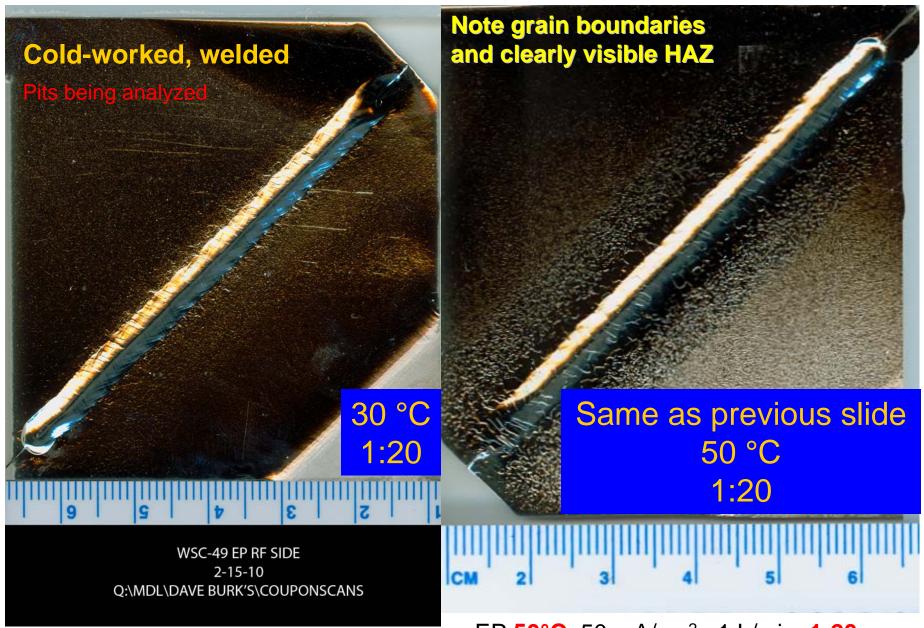
60 nm Ra

>20 pits / 40 cm²

Some larger defects

Cold-worked coupons RF SIDE and reduced to 72 dpi





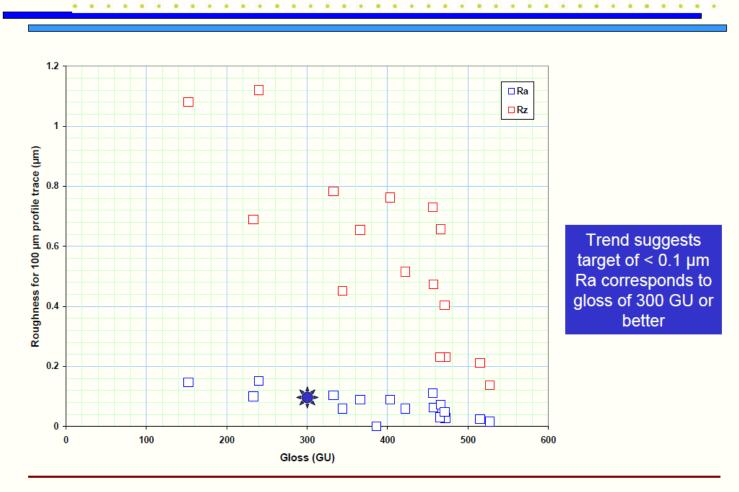
EP **30°C**, 50 mA/cm², 1 L/min, **1:20** ratio of cathode to anode areas, 140 µm removed, 392 GU

EP **50°C**, 50 mA/cm², 1 L/min, **1:20** ratio of cathode to anode areas, 110 μm removed, **125 GU**

Reserve slides

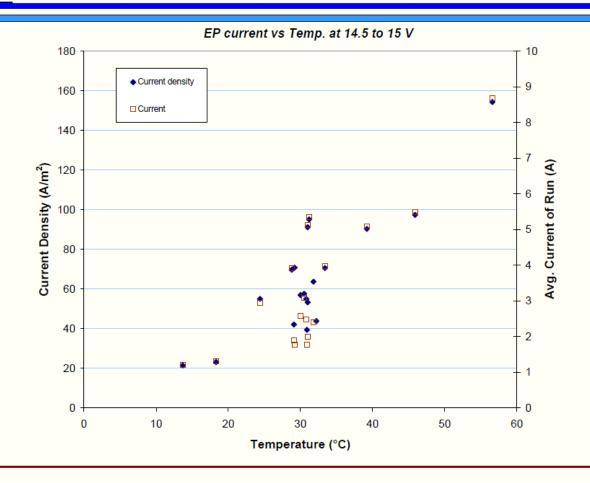
Coupon Roughness vs Gloss





EP Process Data





EP Process Data



Removal rate vs. temperature at target 14.5 V, 50 A/m²

